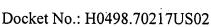
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(PATENT)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Lieber, et al.

Serial No.:

10/588,833

Confirmation No.:

4453

Filed:

August 9, 2006

For:

NANOSTRUCTURES CONTAINING METAL SEMICONDUCTOR

COMPOUNDS

Examiner:

Not Yet Assigned

Art Unit:

2667

Certificate of Mailing Under 37 CFR 1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as First Class Mail, in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Pay 1450, Alexandria, VA. 22313, 1450.

Dated: 13007

TRANSMITTAL LETTER

Mail Stop Amendment Cömmissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed are the following items for filing in connection with the above-referenced Patent Application:

- 1. Preliminary Amendment;
- 2. Information Disclosure Statement
- 3. Application Data Sheet
- 4. Return Receipt Postcard

Application No.: 10/588,833 2 Docket No.: H0498.70217US02

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 23/2825, under Docket No. H0498.70217US02. A duplicate copy of this paper is enclosed.

Dated: 07/30/07

Respectfully submitted,

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